

# Bassem Salem

## List of Publications by Year in descending order

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139  
papers

1,667  
citations

361296

20  
h-index

395590

33  
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141  
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141  
docs citations

141  
times ranked

1606  
citing authors

#	ARTICLE	IF	CITATIONS
1	Tuneable polarity and enhanced piezoelectric response of ZnO thin films grown by metal-organic chemical vapour deposition through the flow rate adjustment. <i>Materials Advances</i> , 2022, 3, 498-513.	2.6	5
2	H3PO4-based wet chemical etching for recovery of dry-etched GaN surfaces. <i>Applied Surface Science</i> , 2022, 582, 152309.	3.1	13
3	Functional Devices from Bottom-Up Silicon Nanowires: A Review. <i>Nanomaterials</i> , 2022, 12, 1043.	1.9	16
4	Implementing the Reactor Geometry in the Modeling of Chemical Bath Deposition of ZnO Nanowires. <i>Nanomaterials</i> , 2022, 12, 1069.	1.9	7
5	Enhancing the incorporation of Sn in vapor-liquid-solid GeSn nanowires by modulation of the droplet composition. <i>Nanotechnology</i> , 2022, 33, 245605.	1.3	0
6	Impact of Substrate Biasing During AlN Growth by PEALD on Al <sub>2</sub> O <sub>3</sub> /AlN/GaN MOS Capacitors. <i>Advanced Materials Interfaces</i> , 2022, 9, 2101731.	1.9	2
7	Verifying the band gap narrowing in tensile strained Ge nanowires by electrical means. <i>Nanotechnology</i> , 2021, 32, 145711.	1.3	6
8	Chemical Bath Deposition of ZnO Nanowires Using Copper Nitrate as an Additive for Compensating Doping. <i>Inorganic Chemistry</i> , 2021, 60, 1612-1623.	1.9	19
9	Smooth plasma etching of GeSn nanowires for gate-all-around field effect transistors. <i>Semiconductor Science and Technology</i> , 2021, 36, 065018.	1.0	4
10	Effects of thermal annealing on the structural and electrical properties of ZnO thin films for boosting their piezoelectric response. <i>Journal of Alloys and Compounds</i> , 2021, 870, 159512.	2.8	21
11	Monolithically integrated InGaAs/AlGaAs multiple quantum well photodetectors on 300Åmm Si wafers. <i>AIP Advances</i> , 2021, 11, .	0.6	5
12	Study of structural and electrical properties of ferroelectric HZO films obtained by single-target sputtering. <i>AIP Advances</i> , 2021, 11, .	0.6	6
13	Development of a robust fabrication process for single silicon nanowire-based omega gate transistors on polyamide substrate. <i>Semiconductor Science and Technology</i> , 2021, 36, 025003.	1.0	3
14	A fabrication process for self-connected horizontal SiGe nanowires. <i>Microelectronic Engineering</i> , 2020, 220, 111150.	1.1	1
15	Analysis of the role of inter-nanowire junctions on current percolation effects in silicon nanonet field-effect transistors. <i>Solid-State Electronics</i> , 2020, 168, 107725.	0.8	4
16	Role played by the nanowire/nanowire junctions in the electrical properties of semiconductor percolating silicon nanowire networks. <i>Journal of Applied Physics</i> , 2020, 128, 204501.	1.1	1
17	Improvement of AlN Film Quality Using Plasma Enhanced Atomic Layer Deposition with Substrate Biasing. <i>ACS Applied Materials &amp; Interfaces</i> , 2020, 12, 39870-39880.	4.0	20
18	Optimization of GOPS-Based Functionalization Process and Impact of Aptamer Grafting on the Si Nanonet FET Electrical Properties as First Steps towards Thrombin Electrical Detection. <i>Nanomaterials</i> , 2020, 10, 1842.	1.9	4

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19	O-Band Emitting InAs Quantum Dots Grown by MOCVD on a 300 mm Ge-Buffered Si (001) Substrate. <i>Nanomaterials</i> , 2020, 10, 2450.	1.9	5
20	Reversible Al Propagation in Si <sub>x</sub> Ge <sub>1-x</sub> Nanowires: Implications for Electrical Contact Formation. <i>ACS Applied Nano Materials</i> , 2020, 3, 10427-10436.	2.4	4
21	Morphology Transition of ZnO from Thin Film to Nanowires on Silicon and its Correlated Enhanced Zinc Polarity Uniformity and Piezoelectric Responses. <i>ACS Applied Materials &amp; Interfaces</i> , 2020, 12, 29583-29593.	4.0	11
22	Impact of droplet composition on the nucleation rate and morphology of vapor-liquid-solid GeSn nanowires. <i>Nanotechnology</i> , 2020, 31, 405602.	1.3	5
23	Material engineering of percolating silicon nanowire networks for reliable and efficient electronic devices. <i>Materials Chemistry and Physics</i> , 2019, 238, 121871.	2.0	12
24	Improvement of the electrical performance of Au/Ti/HfO <sub>2</sub> /Ge <sub>0.9</sub> Sn <sub>0.1</sub> p-MOS capacitors by using interfacial layers. <i>Applied Physics Letters</i> , 2019, 115, 171601.	1.5	4
25	Modeling the Elongation of Nanowires Grown by Chemical Bath Deposition Using a Predictive Approach. <i>Journal of Physical Chemistry C</i> , 2019, 123, 29476-29483.	1.5	18
26	Impact of Wet Treatments on the Electrical Performance of Ge <sub>0.9</sub> Sn <sub>0.1</sub> -Based p-MOS Capacitors. <i>ACS Applied Electronic Materials</i> , 2019, 1, 260-268.	2.0	8
27	Linear and Nonlinear Intersubband Optical Properties of Direct Band Gap GeSn Quantum Dots. <i>Nanomaterials</i> , 2019, 9, 124.	1.9	16
28	Intersubband Optical Nonlinearity of GeSn Quantum Dots under Vertical Electric Field. <i>Micromachines</i> , 2019, 10, 243.	1.4	5
29	Monolithic fabrication of nano-to-millimeter scale integrated transistors based on transparent and flexible silicon nanonets. <i>Nano Futures</i> , 2019, 3, 025002.	1.0	5
30	Formation mechanisms of ZnO nanowires on polycrystalline Au seed layers for piezoelectric applications. <i>Nanotechnology</i> , 2019, 30, 345601.	1.3	10
31	Engineering Self-Assembly of a High- $\chi$ Block Copolymer for Large-Area Fabrication of Transistors Based on Functional Graphene Nanoribbon Arrays. <i>Chemistry of Materials</i> , 2019, 31, 3154-3162.	3.2	12
32	Investigation of GeSn/Ge quantum dots' optical transitions for integrated optics on Si substrate. <i>Results in Physics</i> , 2019, 12, 1732-1736.	2.0	6
33	InAs/GaSb thin layers directly grown on nominal (001)-Si substrate by MOVPE for the fabrication of InAs FINFET. <i>Journal of Crystal Growth</i> , 2019, 510, 18-22.	0.7	3
34	First evidence of superiority of Si nanonet field effect transistors over multi-parallel Si nanowire ones in view of electrical DNA hybridization detection. <i>Materials Research Express</i> , 2019, 6, 016301.	0.8	4
35	Tuning direct bandgap GeSn/Ge quantum dots' interband and intraband useful emission wavelength: Towards CMOS compatible infrared optical devices. <i>Superlattices and Microstructures</i> , 2018, 117, 31-35.	1.4	9
36	Growth of Ge <sub>x</sub> Sn <sub>1-x</sub> Nanowires by Chemical Vapor Deposition via Vapor-Liquid-Solid Mechanism Using GeH <sub>4</sub> and SnCl <sub>4</sub> . <i>Physica Status Solidi (A) Applications and Materials Science</i> , 2018, 215, 1700743.	0.8	18

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37	Electrical characteristics of silicon percolating nanonet-based field effect transistors in the presence of dispersion. Solid-State Electronics, 2018, 143, 83-89.	0.8	5
38	An innovative large scale integration of silicon nanowire-based field effect transistors. Solid-State Electronics, 2018, 143, 97-102.	0.8	20
39	Direct measurement of AC electrokinetics properties and capture frequencies of silicon and silicon-germanium nanowires. Semiconductor Science and Technology, 2018, 33, 015005.	1.0	1
40	Design of Strain-Engineered GeSn/GeSiSn Quantum Dots for Mid-IR Direct Bandgap Emission on Si Substrate. Nanoscale Research Letters, 2018, 13, 172.	3.1	9
41	Understanding and improving the low optical emission of InGaAs quantum wells grown on oxidized patterned (001) silicon substrate. Applied Physics Letters, 2018, 112, .	1.5	2
42	Evaluation of Silicon Nanonet Field Effect Transistor as Photodiodes. Proceedings (mdpi), 2018, 2, 124.	0.2	0
43	Fabrication of top-down gold nanostructures using a damascene process. Microelectronic Engineering, 2017, 177, 41-45.	1.1	6
44	Impact of the wetting layer thickness on the emission wavelength of direct band gap GeSn/Ge quantum dots. Materials Research Express, 2017, 4, 075026.	0.8	3
45	Sub-10-nm plasma nanopatterning of InGaAs with nearly vertical and smooth sidewalls for advanced n-fin field effect transistors on silicon. Journal of Vacuum Science and Technology B: Nanotechnology and Microelectronics, 2017, 35, 021206.	0.6	2
46	Toward the integration of Si nanonets into FETs for biosensing applications. , 2017, , .		3
47	Electrical characterization of percolating silicon nanonet FETs for sensing applications. , 2017, , .		2
48	Fabrication and characterization of a germanium nanowire light emitting diode. Applied Physics Letters, 2017, 111, 233103.	1.5	2
49	Impact of laser anneal on NiPt silicide texture and chemical composition. Journal of Applied Physics, 2017, 121, .	1.1	6
50	On the Development of Label-Free DNA Sensor Using Silicon Nanonet Field-Effect Transistors. Proceedings (mdpi), 2017, 1, .	0.2	4
51	Fabrication and electrical characterization of homo- and hetero-structure Si/SiGe nanowire Tunnel Field Effect Transistor grown by vapor-liquid-solid mechanism. Solid-State Electronics, 2016, 118, 26-29.	0.8	17
52	Thermally activated inter-dots carriers' transfer in InAs QDs with InGaAs underlying layer: Origin and dependence on the post-growth intermixing. Journal of Alloys and Compounds, 2016, 656, 132-137.	2.8	11
53	Fabrication and characterization of silicon nanowire p-i-n MOS gated diode for use as p-type tunnel FET. Applied Physics A: Materials Science and Processing, 2015, 121, 1285-1290.	1.1	13
54	Functionalized silicon nanowires/conjugated polymer hybrid solar cells: Optical, electrical and morphological characterizations. Journal of Luminescence, 2015, 168, 315-324.	1.5	14

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55	Integration of SiC-1D nanostructures into nano-field effect transistors. <i>Materials Science in Semiconductor Processing</i> , 2015, 29, 218-222.	1.9	20
56	Dopant profiling in silicon nanowires measured by scanning capacitance microscopy. <i>Physica Status Solidi - Rapid Research Letters</i> , 2014, 8, 312-316.	1.2	11
57	High density and taper-free boron doped Si <sub>1-x</sub> Ge <sub>x</sub> nanowire via two-step growth process. <i>Journal of Vacuum Science and Technology A: Vacuum, Surfaces and Films</i> , 2014, 32, 041401.	0.9	1
58	Growth strategies to control tapering in Ge nanowires. <i>APL Materials</i> , 2014, 2, .	2.2	16
59	Interfacial abruptness in axial Si/SiGe heterostructures in nanowires probed by scanning capacitance microscopy. <i>Physica Status Solidi (A) Applications and Materials Science</i> , 2014, 211, 509-513.	0.8	6
60	Control of heterointerface and strain mapping in Au catalyzed axial Si-Si <sub>1-x</sub> Ge <sub>x</sub> nanowires. <i>Materials Research Society Symposia Proceedings</i> , 2014, 1707, 37.	0.1	0
61	Carriers' localization and thermal redistribution in post growth voluntarily tuned quantum dashes' size/composition distribution. <i>Journal of Luminescence</i> , 2014, 145, 595-599.	1.5	7
62	Impact of $n$ -type doping on the carrier dynamics of silicon nanowires studied using optical-pump terahertz-probe spectroscopy. <i>Physical Review B</i> , 2014, 89, .	1.1	14
63	Control of the interfacial abruptness of Au-catalyzed Si-Si <sub>1-x</sub> Ge <sub>x</sub> heterostructured nanowires grown by vapor-liquid-solid. <i>Journal of Vacuum Science and Technology A: Vacuum, Surfaces and Films</i> , 2014, 32, .	0.9	4
64	Composition-Dependent Interfacial Abruptness in Au-Catalyzed Si <sub>x</sub> Ge <sub>1-x</sub> /Si/Si <sub>x</sub> Ge <sub>1-x</sub> Nanowire Heterostructures. <i>Nano Letters</i> , 2014, 14, 5140-5147.	4.5	34
65	Hybrid nanocomposites based on conducting polymer and silicon nanowires for photovoltaic application. <i>Journal of Luminescence</i> , 2014, 156, 30-35.	1.5	11
66	Postgrowth intermixing of strain engineered InAs/GaAs quantum dots. <i>Journal of Alloys and Compounds</i> , 2014, 615, 683-686.	2.8	6
67	Distribution of barrier heights in metal/n-InAlAs Schottky diodes from current-voltage-temperature measurements. <i>Materials Science in Semiconductor Processing</i> , 2014, 26, 431-437.	1.9	37
68	Electrical characterisation of horizontal and vertical gate-all-around Si/SiGe nanowires field effect transistors. , 2014, , .		0
69	Effect of HCl on the doping and shape control of silicon nanowires. <i>Nanotechnology</i> , 2012, 23, 215702.	1.3	64
70	Fabrication of SiC Nanopillars by Inductively Coupled SF <sub>6</sub> /O <sub>2</sub> Plasma. <i>Materials Science Forum</i> , 2012, 711, 66-69.	0.3	2
71	ELECTRICAL CHARACTERIZATION OF PLANAR SILICON NANOWIRE FIELD-EFFECT TRANSISTORS. <i>International Journal of Nanoscience</i> , 2012, 11, 1240011.	0.4	0
72	Composition and Size Effects on the Optical Properties of Isolated Silicon-Germanium Nanowires. <i>Materials Research Society Symposia Proceedings</i> , 2012, 1408, 3.	0.1	0

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73	From planar to vertical nanowires field-effect transistors. Materials Research Society Symposia Proceedings, 2012, 1439, 101-107.	0.1	0
74	PiezoNEMS: Semiconductor nanowires and heterostructures for sensing and energy harvesting. , 2012, , .		1
75	Tunable enhancement of light absorption and scattering in Si $\times$ Ge $\times$ nanowires. Physical Review B, 2012, 86, .		
76	Geometrical control of photocurrent in active Si nanowire devices. Nano Energy, 2012, 1, 714-722.	8.2	15
77	High-performance silicon nanowire field-effect transistor with silicided contacts. Semiconductor Science and Technology, 2011, 26, 085020.	1.0	40
78	Quantum confinement effects and strain-induced band-gap energy shifts in core-shell Si-SiO $_2$ nanowires. Physical Review B, 2011, 83, .	1.1	17
79	Coulomb charging effect of electrons in InAs/InAlAs quantum dots studied by capacitance techniques. Physica B: Condensed Matter, 2011, 406, 3531-3533.	1.3	4
80	Temperature Dependent Photoluminescence Properties of InAs/InP Quantum Dashes Subjected to Low Energy Phosphorous Ion Implantation and Subsequent Annealing. Journal of Nanoscience and Nanotechnology, 2011, 11, 9251-9255.	0.9	3
81	Controlled growth of SiGe nanowires by addition of HCl in the gas phase. Journal of Applied Physics, 2011, 110, 024311.	1.1	26
82	Electrical characteristics of a vertically integrated field-effect transistor using non-intentionally doped Si nanowires. Microelectronic Engineering, 2011, 88, 3312-3315.	1.1	17
83	From Si nanowire to SiC nanotube. Journal of Nanoparticle Research, 2011, 13, 5425-5433.	0.8	23
84	Tunnelling current in Schottky diodes containing InAs quantum dots. Superlattices and Microstructures, 2011, 50, 164-172.	1.4	2
85	Growth and characterization of gold catalyzed SiGe nanowires and alternative metal-catalyzed Si nanowires. Nanoscale Research Letters, 2011, 6, 187.	3.1	19
86	Study of CVD nanowire high-k metal interface quality for interconnect level MOS devices. Microelectronic Engineering, 2011, 88, 1228-1231.	1.1	0
87	Wideband frequency and in situ characterization of aluminum nitride (AlN) in a metal/insulator/metal (MIM) configuration. Microelectronic Engineering, 2011, 88, 564-568.	1.1	1
88	Patterned growth of high aspect ratio silicon wire arrays at moderate temperature. Journal of Crystal Growth, 2011, 321, 151-156.	0.7	10
89	InGaAs Quantum Dots Grown by Molecular Beam Epitaxy for Light Emission on Si Substrates. Journal of Nanoscience and Nanotechnology, 2011, 11, 9153-9159.	0.9	4
90	Vertically integrated silicon-germanium nanowire field-effect transistor. Applied Physics Letters, 2011, 99, 193107.	1.5	23

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91	An improved AFM cross-sectional method for piezoelectric nanostructures properties investigation: application to GaN nanowires. <i>Nanotechnology</i> , 2011, 22, 105704.	1.3	33
92	Persistence of In/Ga intermixing beyond the emission energy blueshift saturation of proton-implanted InAs/GaAs quantum dots. <i>Journal of Applied Physics</i> , 2010, 107, .	1.1	1
93	Silicon nanowires: Diameter dependence of growth rate and delay in growth. <i>Applied Physics Letters</i> , 2010, 96, .	1.5	64
94	Impact of ion-implantation-induced band gap engineering on the temperature-dependent photoluminescence properties of InAs/InP quantum dashes. <i>Journal of Applied Physics</i> , 2010, 108, 024317.	1.1	4
95	Surface Recombination Velocity Measurements of Efficiently Passivated Gold-Catalyzed Silicon Nanowires by a New Optical Method. <i>Nano Letters</i> , 2010, 10, 2323-2329.	4.5	56
96	Electrical properties of self-assembled InAs/InAlAs quantum dots on InP. <i>Semiconductor Science and Technology</i> , 2010, 25, 065011.	1.0	3
97	Intermixing of InAs/GaAs quantum dots by proton implantation and rapid thermal annealing. <i>Materials Science in Semiconductor Processing</i> , 2009, 12, 71-74.	1.9	4
98	Self-connected horizontal silicon nanowire field effect transistor. <i>Solid State Communications</i> , 2009, 149, 799-801.	0.9	10
99	Chemical-vapour-deposition growth and electrical characterization of intrinsic silicon nanowires. <i>Materials Science and Engineering B: Solid-State Materials for Advanced Technology</i> , 2009, 159-160, 83-86.	1.7	6
100	Optical investigation of phosphorous-ion-implantation induced InAs/GaAs quantum dots' intermixing. <i>Physics Letters, Section A: General, Atomic and Solid State Physics</i> , 2008, 372, 4714-4717.	0.9	1
101	Capacitance-voltage analysis of InAs quantum dots grown on InAlAs/InP(001). <i>Microelectronics Journal</i> , 2008, 39, 7-11.	1.1	6
102	Inhomogeneous broadening and alloy intermixing in low proton dose implanted InAs/GaAs self-assembled quantum dots. <i>Nanotechnology</i> , 2008, 19, 285715.	1.3	3
103	Effect of the Er-Si interatomic distance on the Er <sup>3+</sup> luminescence in silicon-rich silicon oxide thin films. <i>Journal of Applied Physics</i> , 2007, 102, 103516.	1.1	6
104	Deep level transient spectroscopy studies at low temperature of In <sub>0.52</sub> Al <sub>0.48</sub> As epilayers. <i>Physica B: Condensed Matter</i> , 2007, 391, 18-21.	1.3	2
105	Terahertz emission properties of arsenic and oxygen ion-implanted GaAs based photoconductive pulsed sources. <i>Journal of Vacuum Science and Technology A: Vacuum, Surfaces and Films</i> , 2006, 24, 774-777.	0.9	22
106	Hole emission processes from InAs quantum dots grown on p-type InAlAs/InP(001). <i>Semiconductor Science and Technology</i> , 2006, 21, 311-315.	1.0	5
107	Optical transitions and carrier dynamics in self-organized InAs quantum dots grown on In <sub>0.52</sub> Al <sub>0.48</sub> As/InP(001). <i>Physica E: Low-Dimensional Systems and Nanostructures</i> , 2006, 31, 232-234.	1.3	1
108	Photoluminescence from Er-doped silicon rich oxide thin films. <i>Journal of Luminescence</i> , 2006, 121, 242-244.	1.5	4

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109	Capacitance-voltage profile characteristics of Schottky barrier structure with InAs quantum dots grown on InAlAs/InP(001). <i>Materials Science and Engineering C</i> , 2006, 26, 583-585.	3.8	1
110	Optimizing the spacer layer thickness of vertically stacked InAs/GaAs quantum dots. <i>Materials Science and Engineering C</i> , 2006, 26, 374-377.	3.8	22
111	Post-growth engineering of InAs/GaAs quantum dots <sup>TM</sup> band-gap using proton implantation and annealing. <i>Nanotechnology</i> , 2006, 17, 3707-3709.	1.3	20
112	Improved characteristics of a terahertz set-up built with an emitter and a detector made on proton-bombarded GaAs photoconductive materials. <i>Semiconductor Science and Technology</i> , 2006, 21, 283-286.	1.0	27
113	Size and shape effects on excitons and biexcitons in single InAs-InP quantum dots. <i>Journal of Applied Physics</i> , 2006, 100, 073702.	1.1	18
114	Photoluminescence studies of stacked InAs/InP quantum sticks. <i>Journal of Crystal Growth</i> , 2005, 275, e2327-e2331.	0.7	4
115	Micro-photoluminescence study of single self-organized InAs/InP quantum sticks. <i>Materials Science and Engineering C</i> , 2005, 25, 650-653.	3.8	0
116	Optical properties of 1.3- $\mu$ m room temperature emitting InAs quantum dots covered by In <sub>0.4</sub> Ga <sub>0.6</sub> As/GaAs hetero-capping layer. <i>Applied Physics A: Materials Science and Processing</i> , 2005, 81, 813-816.	1.1	17
117	Arsenic pressure and spacer layer thickness effects on the optical properties of stacked InAs/InAlAs quantum dot array. <i>Physica Status Solidi C: Current Topics in Solid State Physics</i> , 2005, 2, 1399-1403.	0.8	2
118	High-performance terahertz source using ion implanted photoconductive antenna. , 2005, , ,		3
119	Pulsed photoconductive antenna terahertz sources made on ion-implanted GaAs substrates. <i>Journal of Physics Condensed Matter</i> , 2005, 17, 7327-7333.	0.7	39
120	Band gap tuning of InAs-InP quantum sticks using low-energy ion-implantation-induced intermixing. <i>Applied Physics Letters</i> , 2005, 87, 241115.	1.5	18
121	Ion channeling effects on quantum well intermixing in phosphorus-implanted InGaAsP-InGaAs-InP. <i>Journal of Applied Physics</i> , 2005, 98, 054904.	1.1	6
122	Optical transitions and carrier dynamics in self-organized InAs quantum islands grown on InP(001). , 2005, 5734, 27.		0
123	Optical investigation of single self-organized InAs/InP quantum dashes emitting in the 1.3-1.5 $\mu$ m range. <i>Nanotechnology</i> , 2005, 16, 444-447.	1.3	5
124	Effective generation lifetime depth profile in InAs quantum dots grown on InAlAs/InP(001). <i>Semiconductor Science and Technology</i> , 2005, 20, 514-518.	1.0	7
125	From large to low height dispersion for self-organized InAs quantum sticks emitting at 1.55 $\mu$ m on InP(001). <i>Journal of Applied Physics</i> , 2004, 95, 4761-4766.	1.1	79
126	Experimental and theoretical investigation of carrier confinement in InAs quantum dashes grown on InP(001). <i>Journal of Applied Physics</i> , 2004, 95, 1074-1080.	1.1	52



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127	Effect of spacer layer thickness on the optical properties of stacked InAs/InAlAs quantum wires grown on InP (001). <i>Materials Science and Engineering B: Solid-State Materials for Advanced Technology</i> , 2003, 101, 259-261.	1.7	6
128	Evidence of excited levels in self-organized InAs/InP(001) islands with low size dispersion. <i>Physica E: Low-Dimensional Systems and Nanostructures</i> , 2003, 17, 124-126.	1.3	9
129	Optical properties of self-organized InAs nanostructures grown on InAlAs/InP(001). <i>Physica E: Low-Dimensional Systems and Nanostructures</i> , 2003, 17, 180-182.	1.3	7
130	Anti-correlated vertical self-organization of InAs nanowires in stacked structures on InP(001) with InAlAs spacer layer. <i>Physica E: Low-Dimensional Systems and Nanostructures</i> , 2003, 17, 505-506.	1.3	5
131	Spacer layer thickness effects on the photoluminescence properties of InAs/GaAs quantum dot superlattices. <i>Physica Status Solidi A</i> , 2003, 199, 457-463.	1.7	21
132	Dynamic saturation of an intersublevel transition in self-organized InAs/In <sub>x</sub> Al <sub>1-x</sub> As quantum dots. <i>Physical Review B</i> , 2003, 67, .	1.1	11
133	Optical properties of self-assembled InAs quantum dots grown on InAlAs/InP(001). <i>Materials Research Society Symposia Proceedings</i> , 2002, 737, 254.	0.1	1
134	Surface effects on shape, self-organization and photoluminescence of InAs islands grown on InAlAs/InP(001). <i>Journal of Applied Physics</i> , 2002, 92, 506-510.	1.1	98
135	Strong carrier confinement and evidence for excited states in self-assembled InAs quantum islands grown on InP(001). <i>Physical Review B</i> , 2002, 66, .	1.1	35
136	Optical anisotropy and photoluminescence temperature dependence for self-assembled InAs quantum islands grown on vicinal (001) InP substrates. <i>Microelectronics Journal</i> , 2002, 33, 579-582.	1.1	5
137	Optical properties of self-assembled InAs quantum islands grown on InP(001) vicinal substrates. <i>Applied Physics Letters</i> , 2001, 79, 4435-4437.	1.5	38
138	Chemical Stability of Si-SiC Nanostructures under Physiological Conditions. <i>Materials Science Forum</i> , 0, 897, 638-641.	0.3	8
139	Influence of substrate biasing on structural, chemical and electrical properties of Al <sub>2</sub> O <sub>3</sub> thin films deposited by PEALD. <i>Semiconductor Science and Technology</i> , 0, , .	1.0	0